

217713US2



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1-14-3  
Robertson  
Electron

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF:

Jun TATSUTA, et al. : EXAMINER: CRUZ, L.  
SERIAL NO: 10/026,639 :  
FILED: December 27, 2001 : GROUP: 2827  
FOR: SEMICONDUCTOR-CHIP :  
MOUNTING SUBSTRATE AND :  
METHOD OF MANUFACTURING :  
THE SAME

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RESPONSE TO RESTRICTION REQUIREMENT

ASSISTANT COMMISSIONER FOR PATENTS  
WASHINGTON, D.C. 20231

SIR:

In response to the Official Action dated November 29, 2002, Applicants elect with  
traverse the invention of Group I, Claims 1-21, drawn to a semiconductor device.

Applicants respectfully traverse the restriction requirement for the following reason.

MPEP § 803 states:

... If the search and examination of an entire application can  
be made without serious burden, the Examiner must examine it  
on the merits, even though it includes claims to distinct or  
independent inventions.

The claims of the present invention would appear to be part of an overlapping search area.

Accordingly, Applicants respectfully traverse the outstanding requirement on the grounds that  
a search and examination of the entire application would not place a *serious* burden on the  
Examiner.

Therefore, it is respectfully requested that the requirement to elect a single invention be withdrawn, and that a full examination on the merits of Claims 1-26 be conducted.

Respectfully submitted,



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Docket No.: 217713US2

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RE: Application Serial No.: 10/026,639  
Applicants: Jun TATSUTA, et al.  
Filing Date: December 27, 2001  
For: SEMICONDUCTOR-CHIP MOUNTING  
SUBSTRATE AND METHOD OF  
MANUFACTURING THE SAME  
Group Art Unit: 2827  
Examiner: CRUZ, L.

SIR:

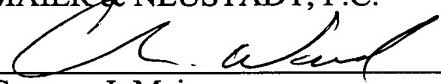
Attached hereto for filing are the following papers:

**RESPONSE TO RESTRICTION REQUIREMENT**

Our check in the amount of \_\_\_\_\_ is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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